



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Uzoh et al. Serial No.: 10/698,878 Filed: October 31, 2003 Title: Methods For Depositing High Yield And Low Defect Density Conductive Films In Damascene Structures	Group Art Unit: 2829 Examiner: Not yet assigned Docket: NT-308-US
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INFORMATION DISCLOSURE STATEMENT

US PATENT DOCUMENTS

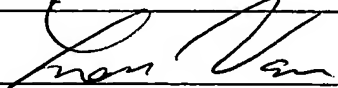
Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
LV		6,303,014	Oct., 2001	Taylor et al.	Copy Enclosed
LV		6,210,555	Apr., 2001	Taylor et al.	Copy Enclosed

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		

OTHER DOCUMENTS

Examiner Initials	Cite No.			Trans- lation

Examiner Signature		Date Considered	9/20/05
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